

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



## PRELIMINARY AMENDMENT ACCOMPANYING SUBMISSION OF MISSING PARTS

APPLICANT:

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**INVENTION:** 

"SEMICONDUCTOR DEVICE USING INTERPOSER SUBSTRATE AND

MANUFACTURING METHOD THEREFOR"

Assistant Commissioner of Patents Washington, D.C. 20231

SIR:

Applicants submit this Preliminary Amendment for consideration in the above-identified patent application:

## IN THE SPECIFICATION

At page 10, line 16, change "Figs. 4A to 4F" to --Figs. 4A to 4J--.

Respectfully submitted,

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FIG. 4A

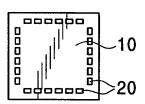


FIG. 4B

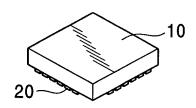


FIG. 4C

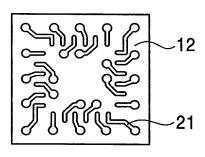


FIG. 4D

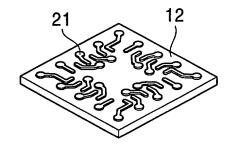


FIG. 4E

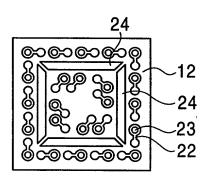


FIG. 4F

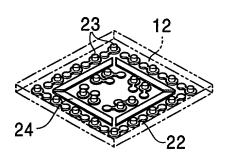


FIG. 4G

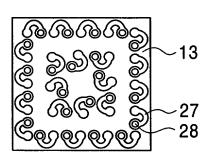


FIG. 4H

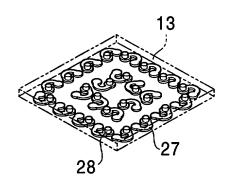


FIG. 41

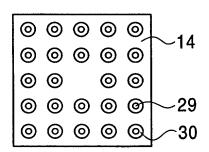


FIG. 4J

